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⑦1 Applicant: **International Business Machines Corporation**
Old Orchard Road
Armonk, N.Y. 10504(US)

(72) Inventor: Hendrick, James Lupton, Jr.
450 Oak Grove, 108
Santa Clara, California 95054(US)
Inventor: Hofer, Donald Clifford

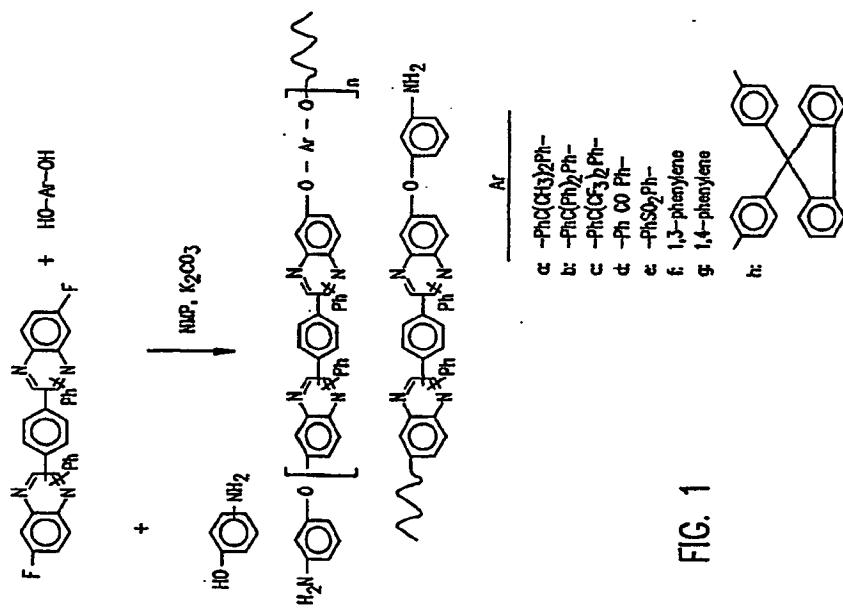
12235 Foothill Avenue
San Martin, California 95046(US)
Inventor: Labadie, Jeffrey William
2292 Maximillian Drive
Campbell, California 95008(US)
Inventor: Swanson, Sally Ann
1566 Ballantree Way
San Jose, California 95118(US)
Inventor: Volksen, Willi
372 El Portal Way
San Jose, California 95123(US)

74 Representative: Burt, Roger James, Dr.
IBM United Kingdom Limited Intellectual
Property Department Hursley Park
Winchester Hampshire SO21 2JN(GB)

54 Polymide-poly(phenylquinoxaline) block copolymers.

57 Block copolymers of polyimide and poly (phenylquinoxaline) are synthesized. They are useful as packaging materials in the electronics industry.

EP 0 420 417 A1



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POLYIMIDE-POLY (PHENYLQUINOXALINE) BLOCK COPOLYMERS

The present invention is concerned with polyimide-poly-(phenylquinoxaline) block copolymers. The block copolymers are useful as packaging materials, particularly as insulator layers in thin film wiring structures on ceramic modules.

Currently used packaging materials for thin film wiring structures fail to meet three major requirements:

- 5 1. Adhesion (glass ceramic and self-adhesion to fully cured polymer)
2. Low stress (low thermal expansion coefficient (TEC) or relaxation mechanism) and
3. Low swell when in contact with N-methylpyrrolidone (NMP).

The poor adhesion observed for many polyimides is often circumvented with adhesion promoters and reactive ion etching (RIE) surface treatments, but the reliability of this approach is suspect in temperature and humidity testing and can lead to corrosion. A film which is low stress and does not swell is desired to avoid cracking, delamination, etc. of the polymer films during fabrication. Biphenyl dianhydride-phenylene diamine (BPDA-PDA) is the best commercially available polyamic acid to meet these requirements, but the adhesion characteristics of this material are poor. Alternatively, Poly (phenylquinoxalines), PPQ, show excellent adhesion characteristics to a wide variety of substrates but these materials cannot be processed from N-methylpyrrolidone (NMP) and have a high TEC.

Ideally a hybrid material (copolymer) can be developed which displays excellent adhesion and low NMP swell like PPQs, the processing characteristics of polyamic esters, and the final properties of rigid or semi-rigid polyimides after cure. There are a number of reports concerning polyimide-phenylquinoxaline based random copolymers, but these materials must be processed from m-cresol. There are no reports of polyimidephenylquinoxaline block copolymers primarily due to the lack of a common solvent system for polyamic acids and PPQs to allow copolymerization, and the difficulty encountered in performing block copolymerizations with polyamic acids of rigid and semi-rigid polyimides. Chemical Abstracts 109:55338r shows the synthesis of polyphenylquinoxalines via aromatic nucleophilic displacement, but it is not concerned with the block copolymers of the present invention.

25 The present invention is a new class of materials, polyimidephenylquinoxaline block copolymers which have the requisite properties to perform as dielectric layers in thin film multilayer structures. A key component of this invention is the ability to synthesize NMP soluble amine terminated PPQ oligomers, which are compatible with polyamic ester synthesis. The synthesis of the PPQ oligomers is carried out using quinoxaline-activated fluoro displacement with bisphenates as the polymer forming reaction. The resulting PPQs have arylene ether linkages in the polymer backbone which leads to the improved solubility in NMP. The amine functional groups are introduced by using aminophenol as a capping agent and the molecular weight can be controlled by using the Caruthers equation, with both mono and difunctional oligomers possible. Another important feature of the copolymerization is the use of polyamic ester chemistry which allows isolation and purification of the final copolymer, which can be reformulated in the desired processing solvent (or solvent mixture). The copolymer synthesis involves treatment of a solution of the PPQ oligomer and the diamine in NMP/CHP (N-cyclohexylpyrrolidone) with the diesterdiacyl chloride. This synthetic scheme was used to prepare both multiblock and triblock copolymers from di- and monofunctional PPQ oligomers, respectively. We have synthesized several series of copolymer using oxydianiline and the diethyl ester diacyl chloride of PMDA with different PPQ oligomers.

30 40 An understanding of the invention will be facilitated by reference to the accompanying drawings.

DESCRIPTION OF THE DRAWINGS

45 Fig. 1 is a diagrammatic sketch using structural formulas showing the synthesis of poly (phenylquinoxaline) PPQ oligomers. In the synthesis quinoxaline-activated fluoro displacement with bisphenates is the polymer forming reaction.

50 Fig. 2 is a diagrammatic sketch using structural formulas showing the copolymer synthesis. The synthesis involves treatment of a solution of the PPQ oligomer (formed in Fig. 1) and a diamine in NMP/CHP with diesterdiacyl chloride.

The thermal and mechanical properties of the copolymers were excellent. Dynamic TGA and isothermal TGA at 400 °C showed the copolymers to have thermal stability comparable to polyimide homopolymers. Dynamic mechanical analysis showed a Tg corresponding to the PPQ block at 250 °C, consistent with PPQ microdomains. The materials showed dimensional stability (retention of modulus) to 450 °C, analogous to

the polyimide homopolymer, with the modulus of the material only dropping approximately one decade above 250 °C. The copolymer displayed tough ductile mechanical properties with moduli in the 2300 MPa range and elongations of approximately 100%. In addition the TECs of the copolymer were about half that of the parent polyimide ranging from 15-22 ppm (thick films).

5 Peel Test experiments were carried out to determine the adhesion of two polymer layers, where the first layer was cured to a specific cure temperature (T_1), then the second layer was solution applied and cured at T_2 . It has been shown that the self adhesion of PMDA-ODA is dependent on the cure temperatures used for each layer. The PMDA-ODA control sample (Du-Pont PI-2540 polyamic acid) showed generally poor self adhesion, particularly when the first layer is fully cured, i.e., $T_1 = 400$ °C. (Table 1) When the same adhesion 10 test was applied with polyimide-PPQ multiblock and triblock copolymers excellent self-adhesion was observed, even when T_1 was 400 °C (Tables 2 and 3). In most cases the films laminated (only one distinguishable layer) and the films could not be peeled. A PPQ composition on the order of 15% appears to be all that is required to obtain dramatically improved adhesion. A further extension of this is to use polyimide-PPQ triblock copolymers blended with PPQ homopolymer (Table 4). Initial results show these 15 materials show good adhesion to glass ceramic substrates without the use of adhesion promoter.

The polyimide-PPQ copolymers showed excellent resistance to NMP swell. Data obtained for both multiblock and triblock copolymers show the swelling in an NMP/CHP mixture to be less than 2%.

In summary, the incorporation of the PPQ into PMDA-ODA via a block copolymer approach affords new 20 hybrid polymers which display the requisite adhesion and low NMP swell required for TFM structures without compromising the desirable properties of the polyimide. The TECs were lower than PMDA-ODA.

In the most preferred embodiments of the present invention, monofunctional oligomers of PPQ are used to give the best microstructure. The most preferred polyimides are those from pyromellitic dianhydride and oxydianiline and from biphenyl dianhydride and phenylenediamine.

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TABLE 1

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PMDA-ODA PI 2540		
T_1 (°C)	T_2 (°C)	PEEL STRENGTH (g/mm)
200	300	15
200	350	10
200	400	10
250	350	9
250	400	9
300	300	2
300	350	5
400	400	0.72

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TABLE 2

PI/PPQ BLOCK COPOLYMERS					
	BLOCK LENGTH	Wt. % PPQ	T ₁ (°C)	T ₂ (°C)	PEEL STRENGTH (g/mm)
5 10 15 20	6.2 K	8	200	400	LAMINATE
	6.2 K	8	400	400	57
	6.2 K	25	400	400	61
	6.2 K	50	400	400	LAMINATE
	15.5 K	13	200	400	LAMINATE
	15.5 K	13	400	400	LAMINATE
	15.5 K	25	400	400	LAMINATE
	15.5 K	50	400	400	LAMINATE
	23 K	15	200	400	LAMINATE
	23 K	15	400	400	LAMINATE

TABLE 3

PI/PPQ (6.0 K) TRIBLOCK			
WT % PPQ	T ₁ (°C)	T ₂ (°C)	PEEL STRENGTH (g/mm)
25 30 35	200	400	LAMINATE
	400	400	LAMINATE
	200	400	LAMINATE
	400	400	LAMINATE

TABLE 4

PI/PPQ BLOCK COPOLYMERS BLENDS					
BLOCK LENGTH	WT. % PPQ	T ₁ (°C)	T ₂ (°C)	PEEL STRENGTH (g/mm)	
40 45 50	6.2 K	13	400	400	56
	6.2 K	13 BLEND R=.2	400	400	25
	6.2 K	13 BLEND R=.5	400	400	11
	15.5 K	13	400	400	LAMINATE
	15.5 K	13 BLEND R=.2	400	400	LAMINATE
	15.5 K	13 BLEND R=.5	400	400	LAMINATE

55 Claims

1) A block copolymer of polyimide and poly (phenylquinoxaline).
 2) A block copolymer as claimed in Claim 1 wherein the polyimide portion is from pyromellitic dianhydride

and oxydianiline.

3) A block copolymer as claimed in Claim 1 wherein the polyimide portion is from biphenyl dianhydride and phenylenediamine.

4) A block copolymer as claimed in Claim 1 wherein the block copolymer is formed from a monofunctional 5 oligomer of poly (phenylquinoxaline).

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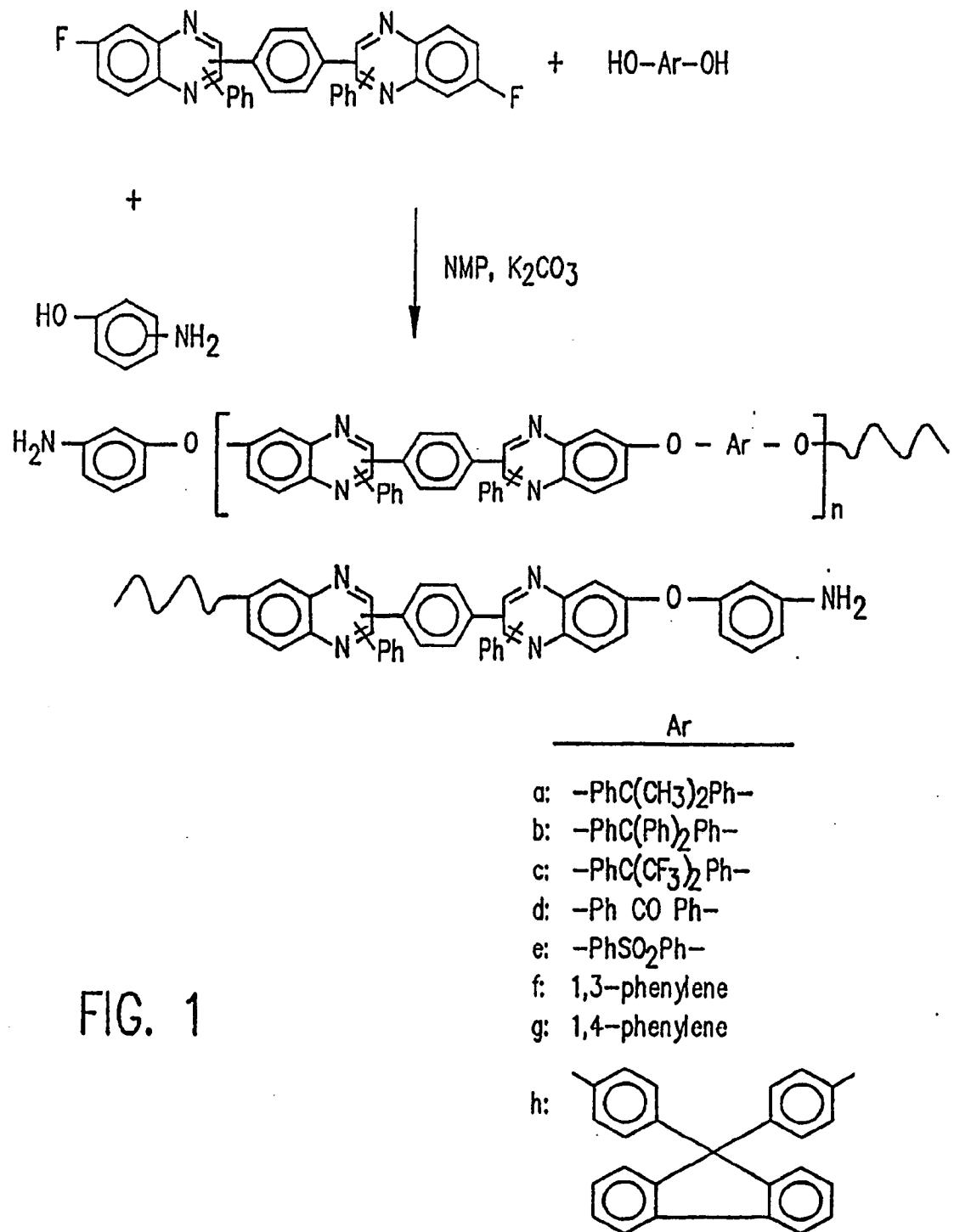


FIG. 1

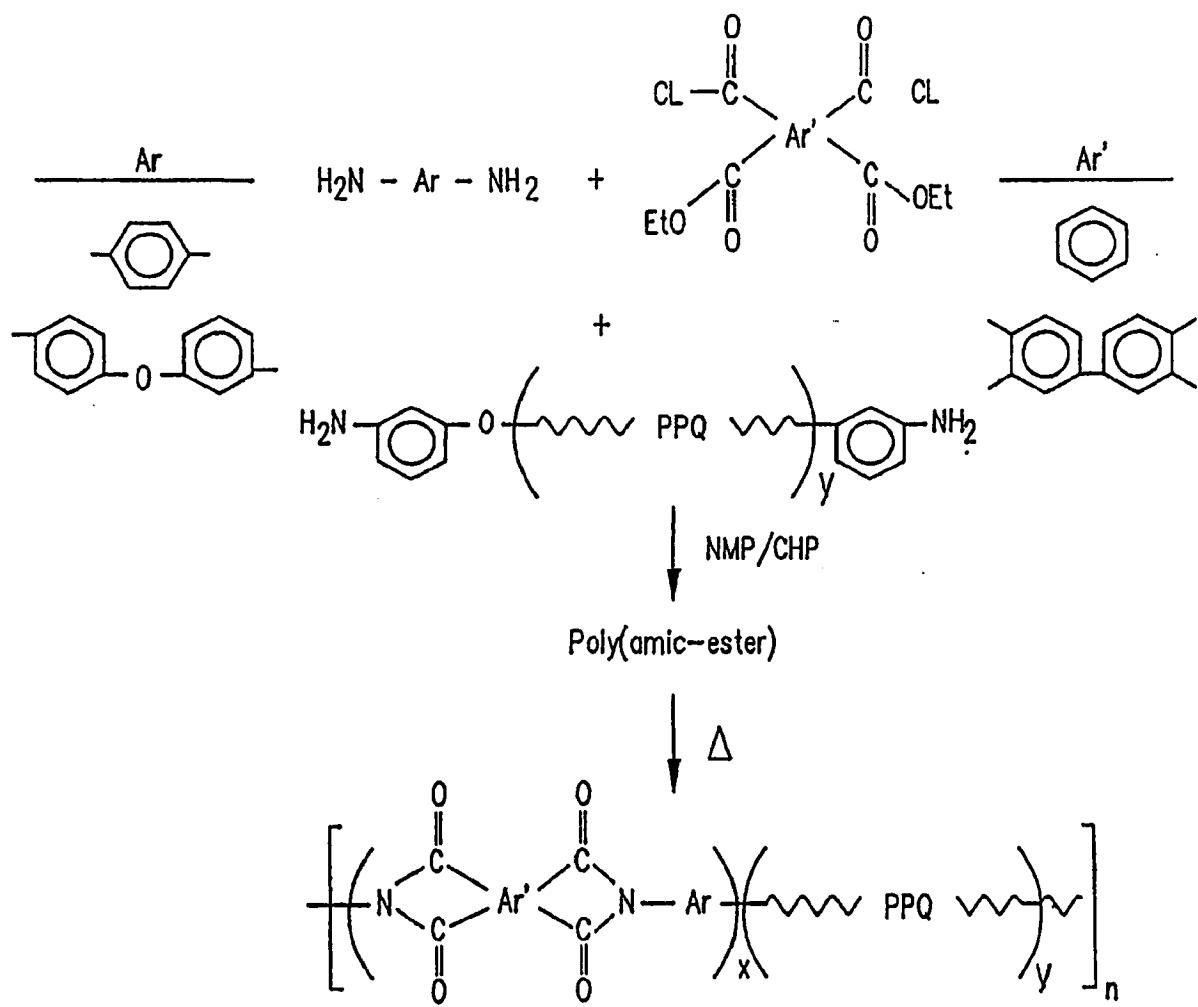


FIG. 2



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EUROPEAN SEARCH
REPORT

Application Number

EP 90 30 9464

DOCUMENTS CONSIDERED TO BE RELEVANT		Relevant to claim	CLASSIFICATION OF THE APPLICATION (Int. Cl.5)		
Category	Citation of document with indication, where appropriate, of relevant passages				
X	CHEMICAL ABSTRACTS, vol. 101, no. 2, 6th August 1984, page 8, abstract no. 38956h, Columbus, Ohio, US; A.L. VDOVINA et al.: "Thermal stability of phenylquinoxaline copolymers", & VYSOKOMOL. SOEDIN., SER. B. 1984, 26(3), 223-7 - - - - -	1-4	C 08 G 73/06 C 08 G 73/10 H 01 B 3/30		
TECHNICAL FIELDS SEARCHED (Int. Cl.5)					
C 08 G					
The present search report has been drawn up for all claims					
Place of search	Date of completion of search	Examiner			
The Hague	30 October 90	LEROY ALAIN			
CATEGORY OF CITED DOCUMENTS					
X: particularly relevant if taken alone					
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